L Number	Hits	Search Text	DB	Time stamp
3	195	(((((mems or microelectromechanical or (micro adj electro	USPAT;	2003/10/21 10:55
		adj mechanical)) and (torsion)) and substrate\$1) and	US-PGPUB;	
1		(electrode\$1 and voltage\$1)) and switch\$3) and array	EPO; JPO;	
			DERWENT;	i
4	7	/////mams or migraplostromoshaning or /migra == sleet	IBM_TDB	2002/40/24 40:54
	,	((((((mems or microelectromechanical or (micro adj electro adj mechanical)) and (torsion)) and substrate\$1) and	USPAT; US-PGPUB;	2003/10/21 10:54
		(electrode\$1 and voltage\$1)) and switch\$3) and array) and	EPO; JPO;	1
		(pass near3 transistor)	DERWENT;	
			IBM TDB	
5	9	((((((mems or microelectromechanical or (micro adj electro	USPAT:	2003/10/21 10:55
		adj mechanical)) and (torsion)) and substrate\$1) and	US-PGPUB;	
		(electrode\$1 and voltage\$1)) and switch\$3) and array) and	EPO; JPO;	
		(voltage\$1 near3 transistor\$1)	DERWENT;	
			IBM_TDB	
6	195	(((((mems or microelectromechanical or (micro adj electro	USPAT;	2003/10/21 10:55
		adj mechanical)) and (torsion)) and substrate\$1) and	US-PGPUB;	
		(electrode\$1 and voltage\$1)) and switch\$3) and array	EPO; JPO;	
			DERWENT;	
7	9	/////mams or microalcotromochanical or (micro adj alcotro	IBM_TDB USPAT:	2003/10/21 10:59
'	Э	((((((mems or microelectromechanical or (micro adj electro adj mechanical)) and (torsion)) and substrate\$1) and	US-PGPUB;	2003/10/21 10:59
		(electrode\$1 and voltage\$1)) and switch\$3) and array) and	EPO; JPO;	
		(voltage\$1 near3 transistor\$1)	DERWENT:	
		(	IBM TDB	
8	28	((((((mems or microelectromechanical or (micro adj electro	USPAT;	2003/10/21 10:59
		adj mechanical)) and (torsion)) and substrate\$1) and	US-PGPUB;	
		(electrode\$1 and voltage\$1)) and switch\$3) and array) and	EPO; JPO;	
		(voltage\$1 same transistor\$1)	DERWENT;	
_			IBM_TDB	
9	19	(((((((mems or microelectromechanical or (micro adj electro	USPAT;	2003/10/21 10:59
		adj mechanical)) and (torsion)) and substrate\$1) and	US-PGPUB;	
		(electrode\$1 and voltage\$1)) and switch\$3) and array) and	EPO; JPO;	
		(voltage\$1 same transistor\$1)) not ((((((mems or microelectromechanical or (micro adj electro adj	DERWENT;	
		mechanical)) and (torsion)) and substrate\$1) and	I IDINI_I DB	
		(electrode\$1 and voltage\$1)) and switch\$3) and array) and		
		(voltage\$1 near3 transistor\$1))	1	
		( totaget near transfert)	<u> </u>	L